

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of	MAIL STOP AFTER FINAL
Shigeru YANO et al.	Group Art Unit: 1771
Application No.: 09/913,725	) Examiner: Hai Vo
Filed: August 17, 2001	) Confirmation No.: 3808
For: POROUS FILM AND MANUFACTURING METHOD THEREOF	) ) ) )

## REPLY AND AMENDMENTS PURSUANT TO 37 C.F.R. §1.116

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action [Final Rejection] mailed January 30, 2004, please reconsider the above-identified patent application as follows:

OK to enter, the 03/291-4